



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shin-Hsin Chang :
Serial No. : 10/623,550 : Group Art Unit #1732
Filed : 22 July 2003 : Examiner: D. T. Beck
Title : MANUFACTURING METHOD FOR
POLYMER CHIPS CONTAINING METAL
OR METAL OXIDE NANOPARTICLES
COMPONENTS

RESPONSE TO RESTRICTION REQUIREMENT
AND AMENDMENT

Mail Stop NO FEE
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant, by the undersigned attorney hereby responds to the outstanding
Official Action dated 29 April 2005 which is a Restriction Requirement. Please
amend the above-referenced patent application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.